IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Laulicht, et al. Customer No. : 21003

Serial No. : 10/577,785 Confirmation No. : 6097

Filed : 07/05/2007 Group Art Unit : 1796

Examiner : Haider, Saira Bano

For : POLYMER-BASED MICROSTRUCTURES

INFORMATION DISCLOSURE STATEMENT

FILED VIA EFS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), applicants bring to the attention of the Examiner the documents listed on the attached Form PTO 1449 and respectfully requests that the listed documents be considered by the Examiner and made of record in the above-captioned application.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed documents are material or constitute "prior art." If the Examiner applies the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of the documents.

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Applicants further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should the documents be applied against the claims of the present application.

Applicants believes no fee is due in connection with this submission. If any additional fee is due, or if any overpayment has been made, the Commissioner is authorized to charge any such fee or credit any overpayment, to our Deposit Account No. 02-4377.

Respectfully submitted,

BAKER BOTTS L.L.P.

11/17/08

Date

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